Environm-MM400 Moisture / Dew Point Hygrometers Stion Analysing

nemation

ency Ultraviolet Gas Production owdered Metals ed Environments

s Manufacturing

Carbon Refining

Food Packaging

s ■ Glove Boxes on Beam ■ R & D ■ Fermentation d Environments Manufacturing ssel Blanketing tion Analysing ncy Ultraviolet Gas Production Ndered Metals Environments anufacturing el Blanketing n Analysing

S Production

ered Metals

ıfacturing

Analysing Ultraviolet

Production



Advanced technologies in process gas measurement for maintenance free analysis. Utilising a state of the art ceramic sensor the MM400 offers excellent long-term reliable and stable moisture analysis from trace levels to ambient air conditions.



Applications

Industrial specialty Gases **Chemical Manufacturing** Plastics Manufacturing

Heat Treating Furnaces Compressed Air Inert Atmosphere Blanketing

Air Dryers Natural Gas Metallurgy

Features & Benefits

- Autoranging from -100°C to +20°C
- RS232/485 outputs
- °C, °F, and ppmv units
- Calibration traceable to NIST
- Remote sensors available

- Fast response and recovery from saturation
- Fault alarm
- Intrinsically Safe Option

nvironments lanufacturing sel Blanketing tion Analysing ncy Ultraviolet Gas Production owdered Metals i Environments Manufacturing arbon Refining ood Packaging ■ Glove Boxes n Beam ■ R & F | Fermentation Environments Manufacturing sel Blanketing ion Analysing cy Ultraviolet ias Productio dered Metal: nvironments Inufacturing Blanketing n Analysing **Production** red Metal 1 ■ R & L Jltraviole[®]

Productio

Maintenance Free

The Systech Illinois 400 Moisture/Dew

Point Hygrometers represent the latest

be customised to your application giving

precise measurements while providing a

simple, yet affordable analyser.

advance in moisture analysis. Designed to

MM410

MM420

MM430

All instruments in the series incorporate our high quality aluminium oxide moisture sensor, providing accurate, dependable results over a wide range from -100°C to +20°C dew point. The aluminium oxide sensor is maintenance-free and is the popular choice for the most demanding

Simply select the instrument configuration and sensor location and let the analyser do the rest.

Cabinetry & Mounting

applications.

The MM400 can be configured in 3 different cabinets. The sensor can be remote mounted from any of these configurations.

Both general purpose and intrinsically safe remote sensors are available:

Three different configurations to match your needs:

- Panel or bench mount
- NEMA 4X / IP66 waterproof and weatherproof
- 19 in. rack mount

Options

- Analogue Outputs
- Alarms
- Remote Sensors

Versatile Configurations

Combine the MM430 with any of our oxygen or carbon dioxide analysers to create a dual gas analyser. Both units fit into a 19" rack mountable cabinet.

Performance Guaranteed

Custom Configuration

This series is designed with the user in mind. These units are completely configurable including the ability to remote mount sensors and offering user-selectable units of Dew Point (°C or °F) or ppmv.

Two versions of the remote sensor are available to meet your needs. The general purpose sensor includes flow valves and can be mounted up to 1km from the analyser. A simple coaxial cable connects the sensor to the instrument.

The intrinsically safe remote sensor allows for installations into hazardous areas. This sensor is approved by BASEEFA and CENELEC to ATEX II 1G/EEx ia IIC T4 standards.



All Systech Illinois' sensors are made to laboratory standards of precision and industrial standards of durability.

Stainless steel housings, lab grade components and controlled environment manufacturing ensure the finest, most consistently precise sensors in the industry.

Principle of Operation

A small, anodized aluminium strip is coated with a very thin layer of gold. The aluminium and gold layers form the two electrodes of an aluminium oxide capacitor. The water vapour penetrates through the gold layer and adheres to the pores of the oxide layer. The number of molecules absorbed on the oxide layer determines the conductivity of the oxide. The value of pore wall resistance provides a value of impedance which is directly related to the water vapour pressure.

....oll6 ontact Lens

inealing

\

amics Comb

Oxygen Defi s **=** High Puri

■ Alloys and

lity ■ Contro

■ Contact Le

keting ■ Hyd

n Analysing

ass/Fibre Opt

uction ■ Elect

vdered Metal

ity ■ Control

■ Contact Ler

Annealing 🔳

ramics Comb

xygen Defic

■ High Purit

Alloys and P

■ Controlled

ntact Lens

aling ■ Ves

cs Combust

n Deficien

and Pow

trolled E : Lens Ma

otics 🛮 G

als ■ Fe

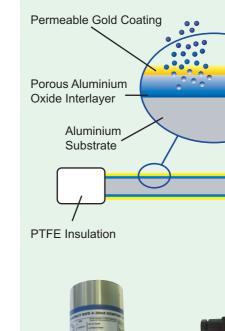
lled En

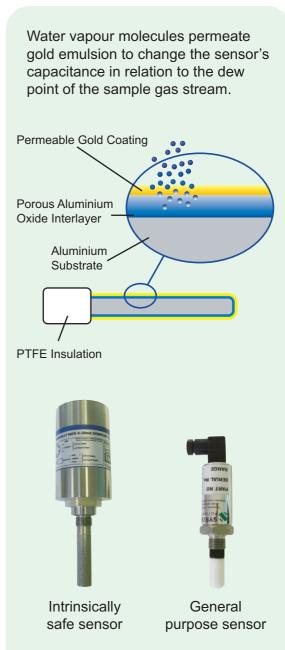
■ Vesse

mbustio

Deficienc

Purity G





MM400 - Moisture / Dew Point Hygrometers



MM410

Bench/Panel Mount 190H x 237W x 410D (mm) 7.9kg



MM420

IP66/NEMA 4X Wall Mount/Weatherproof 404H x 328W x 180D (mm) 13.1kg



MM430

Rack Mount 4U Houses 1 or 2 analysers 178H x 484W x 410D (mm) 9.7kg (single unit)

Technical Specifications

Measurement Ranges Autoranging from -100°C to +20°C and equivalent in ppm(v) moisture

Accuracy ±1°C from -60°C to +20°C

±2°C from -100°C to -60°C

Response Time Wet gas to dry gas: -20°C to -60°C, less than 60 seconds

Dry gas to wet gas: -100°C to -20°C, less than 60 seconds

Selectable Units Dew Point °C / Dew Point °F / ppm(v)

Display Type 5 digit high visibility LED

Operating Conditions Sample and ambient temperature: 0–40°C (32–104°F)

Sample Connections 1/8 in. Swagelock® type, brass

Sample Pressure 0.25 – 28.0 Barg

Sample Flow Independent: ideally 0.5 l/min

Power Requirements 115/230 VAC, 50/60 Hz

Unacceptable Gases Corrosive gases, Mercury, Ammonia, Chlorine, HCl, Ozone

Options

Analogue Outputs Scaleable 0 - 10V, 0 - 100mV and 4 - 20mA all isolated High / low alarms 2 Voltage free with changeover contacts rated 240V 3A

19" Rack Mount Can be combined with many of our other products in a 19" rack mount

configuration

Remote Mounted Sensors General Purpose Sensors can be remote mounted up to 1km away.

Intrinsically Safe Sensors can be mounted up to 200m away.

Systech Illinois have over 25 years experience of providing analysis solutions for a wide range of industries. From our manufacturing plants in the UK and U.S we produce gas analysers for industrial process industries, headspace analysers for monitoring gas flushing of food products, and our range of permeation analysers.

Systech Instruments Ltd (UK) 17 Thame Park Business Centre,

Wenman Road, Thame, Oxfordshire OX9 3XA Tel: +44 (0)1844 216838

Fax: +44 (0)1844 217220 E-mail: advice@systech.co.uk www.systechillinois.com

Illinois Instruments, Inc (U.S)

2401 Hiller Ridge Road Johnsburg, Illinois 60051

U.S.A

Tel: +1 815 344 6212 Fax: +1 815 344 6332

E-mail: sales@illinoisinstruments.com www.systechillinois.com

Illinois Instruments (Thailand)

6th fl Nopnarong Bldg No7 Ladprao23, Jatujak, Bangkok 10900 Thailand

Tel: +66 (0)2938 0798 Fax: +66 (0)2938 1058

E-mail: mai@illinoisinstruments.com www.systechillinois.com

Systech Illinois (China)

Room 519, No.3 FuCheng Building
No. 900 Quyang Rd, Hongkou district,
Shanghai, China 200434
Tel: +86 21 65533022
Fax: +86 21 65539651
Email: info@systechillinois.cn
www.systechillinois.cn

pallonn ontact Lens I inealing ■ Ve amics Combu Oxygen Defici s
High Purity Alloys and P lity ■ Controlle ■ Contact Len keting ■ Hydro on Analysing **•** ass/Fibre Optio uction ■ Electro Ndered Metals ity ■ Controlle ■ Contact Lens Annealing ■ Ve ramics Combus Oxygen Deficie ■ High Purity Alloys and Pov ■ Controlled | ontact Lens M aling ■ Vesse s Combustic n Deficiency h Purity Gas and Powd ntrolled Env t Lens Mar ens Mani ■ Vessel I ombustion Deficiency **Purity Gas**